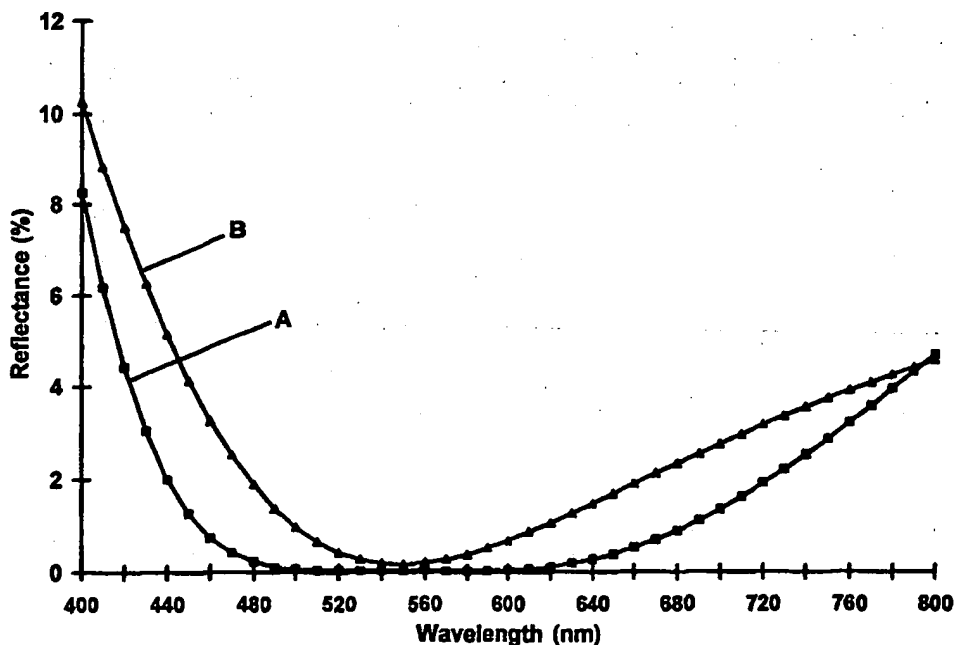




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(54) Title: ANTIREFLECTION FILM



(57) Abstract

An antireflection coating comprises one or more inorganic antireflection layers (typically metal oxide or silica layers) and a polymer layer cured *in situ*, the polymer layer having a refractive index not greater than about 1.53 over the wavelength range of 400 to 700 nm and a thickness of from about 20 to about 200 nm. The polymer layer provides good scratch and fingerprint protection and also enables the thicknesses of the inorganic antireflection layers to be reduced, thereby reducing the cost of the coating.

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ANTIREFLECTION FILM

This invention relates to a process for providing an antireflection film on a substrate, and to the article formed by this process.

It has long been known that it is advantageous to provide various articles, for example lenses, cathode ray tubes, flat panel displays, window films and windshields, with antireflection films which reduce the amount of light reflected from the surface of the article and thus reduce or eliminate "ghost" images formed by such reflected light. For example, US-A-5 106 671; US-A-5 171 414 and US-A-5 234 748 describe antireflection films which are placed on the inside surface of automobile windshields to reduce the intensity of the image of the instrument panel caused by light reflected from the inside surface of the windshield.

Antireflection coatings on a substrate typically comprise a plurality of inorganic layers, for example a metal or metal oxide layer and a silica layer. (The term "silica" is used herein in accordance with its normal meaning in the antireflection art to mean a material of the formula SiO_x where x is not necessarily equal to two. As those skilled in the art are aware, such silica layers are often deposited by chemical vacuum deposition or sputtering of silicon in an oxygen atmosphere, so that the material deposited does not precisely conform to the stoichiometric formula SiO_2 of pure silica.) Typically, one surface of a silica layer is exposed, and this exposed surface, which has a high surface energy, as shown by its low contact angle with water, is highly susceptible to fingerprints and other marks. Such marks are extremely difficult to clean, often requiring the use of chemical cleaners.

US-A-4 765 729 describes an anti-reflection optical article, which comprises a substrate bearing a single-layer or multi-layer anti-reflection film having a surface film composed of an inorganic substance, and a coating of an organic substance containing a curing material formed on the surface of the anti-reflection film, wherein the surface reflectance of the optical article is lower than 3% and the stationary contact angle to water is at least 60° . The inorganic substance is preferably silica and the preferred curing material is a silanol-terminated polysiloxane.

According to this patent, the thickness of the organic substance should be in the range of 0.0005 to 0.5 μm (0.5 to 500 nm), especially 0.001 to 0.3 μm (1 to 300 nm). The provision of the layer of organic substance is stated to increase the scratch and stain resistance of the optical article.

5 However, this patent gives no directions for controlling the thickness of the organic substance within the very broad range which it suggests for such thickness, and all of the worked examples use a dip coating technique which would lead to very thin coatings the thickness of which would be expected to vary significantly over the surface of the coated substrate, since the coating solution will
10 accumulate at the lowest point on the substrate. Furthermore, in these worked examples, a substrate such as a lens is first provided with antireflection layers of metal oxide and silica to a total thickness of $\lambda/4$ and then the organic substance is applied by dip coating. In these circumstances, proper antireflection properties will be obtained only if the organic substance is very thin, less than 10 nm, so that it has
15 essentially no effect on the optical properties of the antireflection coating, and as already indicated, it is difficult to achieve uniformity in such very thin coatings.

 Perhaps the most effective antireflection film available commercially is that sold by Southwall Technologies, 1029 Corporation Way, Palo Alto, California 94303, United States of America. This material comprises a 180 μm poly(ethylene
20 terephthalate) substrate provided with an abrasion-resistant hard coat, and then successively with a 17 nm indium tin oxide (ITO) layer, a 23 nm silica layer, a 95 nm ITO layer, an 84 nm silica layer and finally a thin "lubrication" layer, which is formed from a fluoropolymer and is stated to improve the scratch resistance and the susceptibility of the surface to marking.

25 This complex film possesses excellent antireflection characteristics, but is so expensive (approximately US\$10 per square foot, US\$100 m^{-2}) as to preclude its use in many applications where antireflection films are desirable. Much of the high cost of this film can be attributed to the 95 nm ITO layer and 84 nm silica layer; since these layers are typically formed by sputtering, and the cost of a sputtered

layer is directly proportional to its thickness. Furthermore, if it is desired to produce large quantities of such a complex film on a production line basis, the need for four separate sputtering stations, all of which must be maintained under high vacuum, results in a complex and costly apparatus.

5 It has now been found that providing a "thick" (i.e., optically active) polymer layer of carefully controlled refractive index above an inorganic antireflection layer or layers, the thickness(es) of the inorganic layer(s) can be greatly reduced, thereby reducing the overall cost of the antireflection coating, especially when the inorganic layer(s) is/are applied by a process such as sputtering or chemical
10 vapor deposition in which the residence time of the substrate within the coating apparatus is directly proportional to the thickness of the required layer. Also, an antireflection coating using such a thick polymer layer, which can readily be applied with good uniformity by solution or other coating techniques, has good scratch and stain resistance.

15 Accordingly, this invention provides a process for providing an antireflection film on a substrate. This process comprises depositing an inorganic antireflection layer on the substrate. The process is characterized by depositing a layer of a curable composition on the inorganic antireflection layer, and effecting free radical curing of the deposited curable composition to form a polymer layer having a
20 thickness of from 20 to 200 nm and a refractive index not greater than 1.53 over the wavelength range of 400 to 700 nm.

 This invention also provides an article provided with an antireflection film by the process described above

25 In the present process, the curing of the curable composition may be effected by cross-linking of one or more polymers or oligomers, or by polymerization of one or more monomers or oligomers, or by a combination of both cross-linking and polymerization. Such curing techniques are familiar to those skilled in polymer technology.

The accompanying drawing shows reflectance curves for two preferred antireflection films of the present invention prepared in the Example below.

As already indicated, the article of the present invention is provided with an antireflection film comprising one or more inorganic antireflection layers and an outer polymer layer. The polymer layer has a thickness of from 20 to 200 nm and a refractive index not greater than 1.53 over the visible wavelength range of 400 to 700 nm, and is formed on the inorganic antireflection layer(s) by depositing a layer of a curable composition and then curing this layer *in situ*. The relatively thick layer of curable composition required can be applied with good uniformity by solution coating or other conventional coating techniques. Also, the provision of the thick polymer layer enables the thickness, and thus the cost, of the inorganic antireflection layers to be reduced. For example, one embodiment of the invention described below comprises a 19 nm indium tin oxide layer, a 20 nm silica layer and an 85 nm polymer layer; as compared to the Southwall Technology antireflection film described above, this embodiment of the invention reduces the amount of material which needs to be sputtered per unit area of the film by about 80 percent, thus reducing the cost of the film by more than 50 percent.

The substrate of the present article can be any material on which an antireflection coating is desired, provided of course that the substrate can withstand the (relatively mild) conditions needed for deposition of the various layers and the curing of the curable composition. The substrate may be a finished optical article, for example a lens, the display surface of a cathode ray tube, or an automobile windshield. However, in most cases it is preferred that the substrate be a plastic film, typically a polyester film; the plastic film has the antireflection coating formed thereon, and the resultant antireflection film may be applied to, for example, a cathode ray tube, a flat panel display, window glass or a windshield, which it is desired to provide with antireflection characteristics. Suitable polyester films are readily available commercially, for example the 4 to 7 mil (101 to 177 μm)

poly(ethylene terephthalate) films sold under the trademark "MELINEX" by ICI Americas Inc., Wilmington, Delaware.

Especially when the substrate is a plastic film, it may be provided with coatings on one or both surfaces to improve its hardness and scratch resistance, to improve the adhesion of the inorganic antireflection layer to the substrate, or to provide any other desired properties, for example filtration of ultra-violet radiation or provision of a gas and/or moisture barrier. A hard coating on the substrate will typically have a thickness of about 1 to about 15 μm , preferably from about 2 to about 3 μm , and such a hard coating may be provided by free radical polymerization (initiated either thermally or by ultra-violet radiation) of an appropriate polymerizable material. An especially preferred hard coat for use in the present invention is the acrylic polymer coating sold under the trademark "TERRAPIN" by Tekra Corporation, 6700 West Lincoln Avenue, New Berlin, Wisconsin 53151, United States of America.

As already indicated, the article of the present invention may include one or more than one inorganic antireflection layers. These layers may be formed from any of the inorganic materials hitherto used in antireflection coatings. The preferred materials for forming the inorganic antireflection layer on which the curable composition is deposited are metal oxides and silica layer. Preferred metal oxides are indium oxide, titanium dioxide, cadmium oxide, gallium indium oxide, niobium pentoxide, indium tin oxide and tin dioxide, with indium tin oxide being especially preferred.

As will be apparent to those skilled in thin film optics and the design of antireflection coatings, the thicknesses of the inorganic antireflection layer(s) and the polymer layer in the present article should be correlated so that the total thickness of these layers is approximately $\lambda/4$ of the center of the wavelength range for which antireflection characteristics are desired, e.g., the total thickness should be approximately 135-145 nm when antireflection characteristics are desired over the entire visible range of 400 to 700 nm. Also, the thicknesses of the inorganic

antireflection layer(s) and the polymer layer can be adjusted relative to one another to produce minimum reflectivity from the composite film.

5 In one preferred article of the present invention having a metal oxide layer in contact with the polymer layer, this metal oxide layer is the sole inorganic antireflection layer and has a thickness of 10 to 30 nm, desirably 17 to 23 nm, while the accompanying polymer layer has a thickness of 80 to 150 nm, desirably 110 to 130 nm. This preferred article combines low production cost with good antireflection properties.

10 When the inorganic layer in contact with the polymer layer is a silica layer, a preferred article of the invention comprises a metal oxide layer on the substrate and a silica layer superposed on the metal oxide layer, the polymer layer being superposed on the silica layer. In such a two inorganic layer structure, desirably the metal oxide layer has a thickness of from 10 to 30 nm, preferably 10 to 20 nm, the silica layer desirably has a thickness of from 10 to 120 nm, preferably 10 to 50 nm, and the polymer layer desirably has a thickness of from 50 to 130 nm, preferably 60 to 100 nm.

20 A third preferred article of the present invention having a metal oxide layer in contact with the polymer layer comprises a first metal oxide layer, a silica layer superposed over the first metal oxide layer, and a second metal oxide layer superposed on the silica layer, the polymer layer being superposed on the second metal oxide layer. In this structure, the first metal oxide layer desirably has a thickness of from 20 to 35 nm, preferably 25 to 30 nm, the silica layer desirably has a thickness of from 10 to 25 nm, preferably 15 to 20 nm, the second metal oxide layer desirably has a thickness of from 50 to 100 nm, preferably 65 to 80 nm, and the
25 polymer layer desirably has a thickness of from 70 to 120 nm, preferably 85 to 100 nm. This preferred three inorganic layer structure provides antireflection performance substantially equal to that of the Southwall Technology four inorganic layer structure discussed above, while still providing a substantial reduction in

production costs, since the thick silica layer and the thin lubrication layer of the four inorganic layer structure are eliminated.

Although other techniques, for example e-beam and thermal evaporation may be employed to deposit the inorganic layers of the present article, these layers are preferably deposited by sputtering or by chemical vapor deposition, with dc sputtering being especially preferred, although RF, magnetron and reactive sputtering and low-pressure, plasma-enhanced and laser-enhanced chemical vapor deposition may also be used. When the preferred plastic film substrates are used, the deposition of each of these layers should of course be effected at a temperature which does not cause damage to the plastic substrate; this temperature limit of course varies with the exact plastic substrate employed.

As already indicated, the polymer layer of the present antireflection coating has a refractive index not greater than about 1.53 over the wavelength range of 400 to 700 nm and a thickness of from 20 to 200 nm. The preferred thickness range for this layer is 50 to 130 nm, preferably 60 to 100 nm. Polymer layers having thicknesses within these ranges are readily prepared by depositing a solution of an appropriate curable material in an organic solvent using conventional solution coating techniques, for example slot coating, removing the solvent and curing the resultant layer of curable material.

It is desirable to keep the refractive index of the polymer layer as low as possible consistent with other acceptable properties for this layer, especially hardness and scratch and stain resistance. The polymer should also be resistant to cleaning solvents which may be used on the film, for example ethyl alcohol, aqueous ammonia, acetone, gasoline and isopropanol, and food and cosmetic items, for example peanut butter and lipstick with which it may come into contact. Finally, the polymer should also have good durability, as measured, for example by its ability to withstand rubbing with steel wool. Desirably, the polymer layer has a refractive index below about 1.50 over the entire visible range of 400 to 700 nm. To provide a suitably low refractive index, the curable composition used to form the polymer

layers desirably comprises a polymer of a fluoroalkene, for example poly(vinylidene fluoride) or a vinylidene fluoride/tetrafluoroethylene copolymer, such as the material sold under the trademark "KYNAR" by San Diego Plastics, Inc., 2220 McKinley Avenue, National City, California 91950, United States of America. However, since
5 a polymer layer consisting only of a fluoroalkene polymer will typically be too soft to give good scratch protection, it is also desirable that the curable composition include an alkyl acrylate or methacrylate polymer, such as the material sold under the trademark "ELVACITE 2041" by ICI Acrylics, Inc., 3411 Silverside Road-McKean 2nd, Wilmington, Delaware 19850-5391, United States of America, or that sold
10 under the trademark "ACRYLOID A21" by Rohm and Haas, 100 Independence Mall West, Philadelphia, Pennsylvania 19106-2399, United States of America. To promote cross-linking within the polymer layer, and thus increase the hardness of this layer, it is advantageous to include a polyfunctional acrylate monomer ("polyfunctional" being used herein in its conventional sense to denote a material
15 having a functionality of 3 or higher) in the curable composition; a specific preferred polyfunctional acrylate monomer is that sold under the trademark "SR 399" by Sartomer, Inc., 502 Thomas Jones Way, Exton, Pennsylvania 19341, United States of America; this material is stated by the manufacturer to be dipentaerythritol pentaacrylate.

20 It is well known to those skilled in polymer science that most polymers have a negative dispersion with the visible range, i.e., their refractive index at 700 nm is smaller than their refractive index at 400 nm. Calculations show that such negative dispersion adversely affects the antireflection properties of the film and hence it is desirable to reduce such negative dispersion as far as possible. The
25 aforementioned KYNAR polymer has a low refractive index and small negative dispersion, which render it very suitable for use in the present curable composition. While the desirability of a fluoroalkene polymer to provide low refractive index in the polymer layer and for an acrylate or methacrylate cross-linker to provide hardness in the same layer might suggest that the properties of the polymer layer must inevitably

involve a compromise between the two properties, it has been found that, if the formulation of the curable composition is carefully chosen, segregation of material occurs spontaneously during curing, resulting in a polymer layer having an outer portion enriched in the acrylate or methacrylate polymer (and thus of enhanced hardness) and an inner portion enriched in the fluoroalkene polymer (and thus of reduced refractive index). An additional benefit of such segregation of acrylate or methacrylate polymer material during curing is that it enables the cross-linking to occur in an oxygen-containing atmosphere, such as air, thereby avoiding the need for a nitrogen blanket as is customary during thin film ultra-violet curing, and thus reducing the cost of manufacture of the antireflection film.

The curable composition may be cured by any conventional method, but is desirably cured by a free radical curing, which may be initiated either thermally or by ultra-violet radiation, although the latter is generally preferred. Persons skilled in polymer technology will be familiar with appropriate initiators, oxygen scavengers and other components useful in such free radical curing. However, it should be noted that, because of the extreme thinness of the polymer layer desired in the present process, the type and proportion of initiator(s) required may differ from typical formulations intended for production of thicker polymer layers.

Preferred embodiments of the present invention will now be described, though by way of illustration only, to show preferred reagents, conditions and techniques used in the present process.

Example 1

In the preferred process, a 4 mil (101 μm) poly(ethylene terephthalate) film was solvent coated on one surface with the aforementioned TERRAPIN acrylic polymer coating, the solvent was allowed to evaporate and the film was placed under an ultra-violet lamp to cure the polymer. The coated surface of the film was then coated by direct current sputtering (chemical vapor deposition may alternatively be used) with a 19 nm layer of indium tin oxide and then with a 20 nm layer of silica.

A liquid curable composition was then prepared having the following composition (the proportions are by dry weight of the solution):

	% by weight
Poly(vinylidene fluoride) (KYNAR)	46.8
5 Methyl methacrylate (ACRYLOID A21)	6.9
Dipentaerythritol pentaacrylate (Sartomer SR 399)	30.7
Multifunctional acrylate monomer (Sartomer CD9051)	3.0
Coating additive (COATOSIL 3503 ¹)	4.0
Adhesion promoter (SILANE A174 ¹)	1.0
10 Curing initiator (DARACURE 1173 ²)	2.0
Curing initiator (QUANTACURE BMS ³)	4.0
Oxygen scavenger (DIDMA ⁴)	1.6

Notes:

1. Both available from OSi Specialties, 39 Old Ridgebury Road,
15 Danbury, Connecticut 06810-5121, United States of America.
2. Available from Ciba-Geigy Corporation, 540 White Plains
Road, P.O. Box 2005, Tarrytown, New York 10591-9005, United States of America.
3. Manufactured by Great Lakes Chemical Corporation, and
available from Biddle Sawyer Corporation, 2 Penn Plaza, New York, New York
20 10121, United States of America.
4. Available from Aldrich Chemical Company, 1001 West St.
Paul, Milwaukee, Wisconsin 53233, United States of America.

The various components were prepared as stock solutions in methyl
ethyl ketone (MEK), at 20 percent w/w, except that the ACRYLOID A21 and
25 QUANTACURE BMS were prepared at 10 percent w/w, and the DARACURE and
DIDMA were prepared at 5 percent w/w. The requisite quantities of the various
stock solutions were then mixed, together with sufficient additional MEK to give
2000 g of a coating solution containing 2.75 percent solids w/w. This coating
solution was then coated via a slot coater on to the film bearing the metal oxide and

silica layers, the solvent allowed to evaporate and the film placed under an ultra-violet lamp to produce a polymer coating approximately 85 nm thick.

5 The resultant antireflection article of the present invention had a low surface reflection, and exhibited good resistance to scratching with steel wool or fingerprinting. The article had a contact angle with water of approximately 89°, in contrast to the contact angle of 14-26° for a bare silica surface with no polymer coating.

Example 2

10 Example 1 was repeated, except that only a 20 nm layer of indium tin oxide was deposited on the substrate (provided with the hard coat) and that the thickness of the polymer layer formed was 120 nm.

Example 3

15 Example 1 was repeated, except that there were deposited successively on the substrate (provided with the hard coat) a 27.5 nm layer of indium tin oxide, a 17.5 nm layer of silica, a 73 nm layer of indium tin oxide, and a 94 nm layer of the same polymer as in Example 1.

The accompanying drawing shows reflectance curves for two preferred films of the invention:

20 Curve A: A two inorganic layer structure prepared in the same manner as in Example 1 but having a 19 nm indium tin oxide layer, a 40 nm silica layer and an 82.5 nm polymer layer.

Curve B: The film prepared in Example 3 above.

25 From these Curves, it will be seen that both films displayed very good antireflection characteristics, with the more expensive three inorganic layer film of Example 3 displaying a reflectance below 1.5 percent over the range of 450-700 nm. (Later experiments with similar films have produced reflectance as low as 0.8 percent over this wavelength range.) The photopic reflectance value for Curve A (measured according to CIE 1931, which specifies a weighted average of the reflectance over the spectral range of 450 to 650 nm centered at 550 nm and weighted mostly highly

at this wavelength) was 0.609 percent, while the corresponding value for Curve B was 0.085 percent. (The 40 nm silica layer used in the film which produced Curve A minimized the photopic reflectance value of the film. However, decreasing the thickness of the silica layer to 20 nm only increases this value only to 0.610 percent, and the cost reduction associated with the reduced silica thickness is such that in practice the 20 nm thickness used in Example 1 is preferred.)

It will be apparent to those skilled in the relevant art that numerous changes and modifications can be made in the preferred embodiment of the invention described above without departing from the scope of the invention. For example, the metal oxide layer might be replaced by a layer of a different material which can bond to and form an antireflection coating with silica. The polymer layer described above could then be formed on the silica surface in the manner already described.

CLAIMS

- 1 1. A process for providing an antireflection film on a substrate,
2 the process comprising:
3 depositing an inorganic antireflection layer on the substrate,
4 the process being characterized by:
5 depositing a layer of a curable composition on the inorganic
6 antireflection layer; and
7 effecting free radical curing of the deposited curable composition to
8 form a polymer layer having a thickness of from 20 to 200 nm and a refractive index
9 not greater than 1.53 over the wavelength range of 400 to 700 nm.
- 1 2. A process according to claim 1 characterized in that the
2 inorganic antireflection layer comprises at least one of indium oxide, titanium dioxide,
3 cadmium oxide, gallium indium oxide, niobium pentoxide, indium tin oxide and tin
4 dioxide.
- 1 3. A process according to either of the preceding claims
2 characterized in that a single layer of a metal oxide having a thickness of from 10 to
3 30 nm is deposited on the substrate and a polymer layer having a thickness of from
4 80 to 150 nm is formed on this single metal oxide layer.
- 1 4. A process according to claim 1 or 2 characterized in that a
2 metal oxide layer is deposited upon the substrate, a silica layer is deposited on the
3 metal oxide layer and the polymer layer is formed on the silica layer.
- 1 5. A process according to claim 1 or 2 characterized in that a first
2 metal oxide is deposited on the substrate; a silica layer is deposited on the first metal
3 oxide layer; a second metal oxide layer is deposited on the silica layer, and the
4 polymer layer is formed on the second metal oxide layer.
- 1 6. A process according to any one of the preceding claims
2 characterized in that the polymer layer has a refractive index not greater than 1.50
3 over the wavelength range of 400 to 700 nm.

1 7. A process according to any one of the preceding claims
2 characterized in that the curable composition comprises at least one of:

- 3 (a) a polymer of a fluoroalkene
4 (b) a polymer of an alkyl acrylate or methacrylate; and
5 (c) a polyfunctional acrylate monomer.

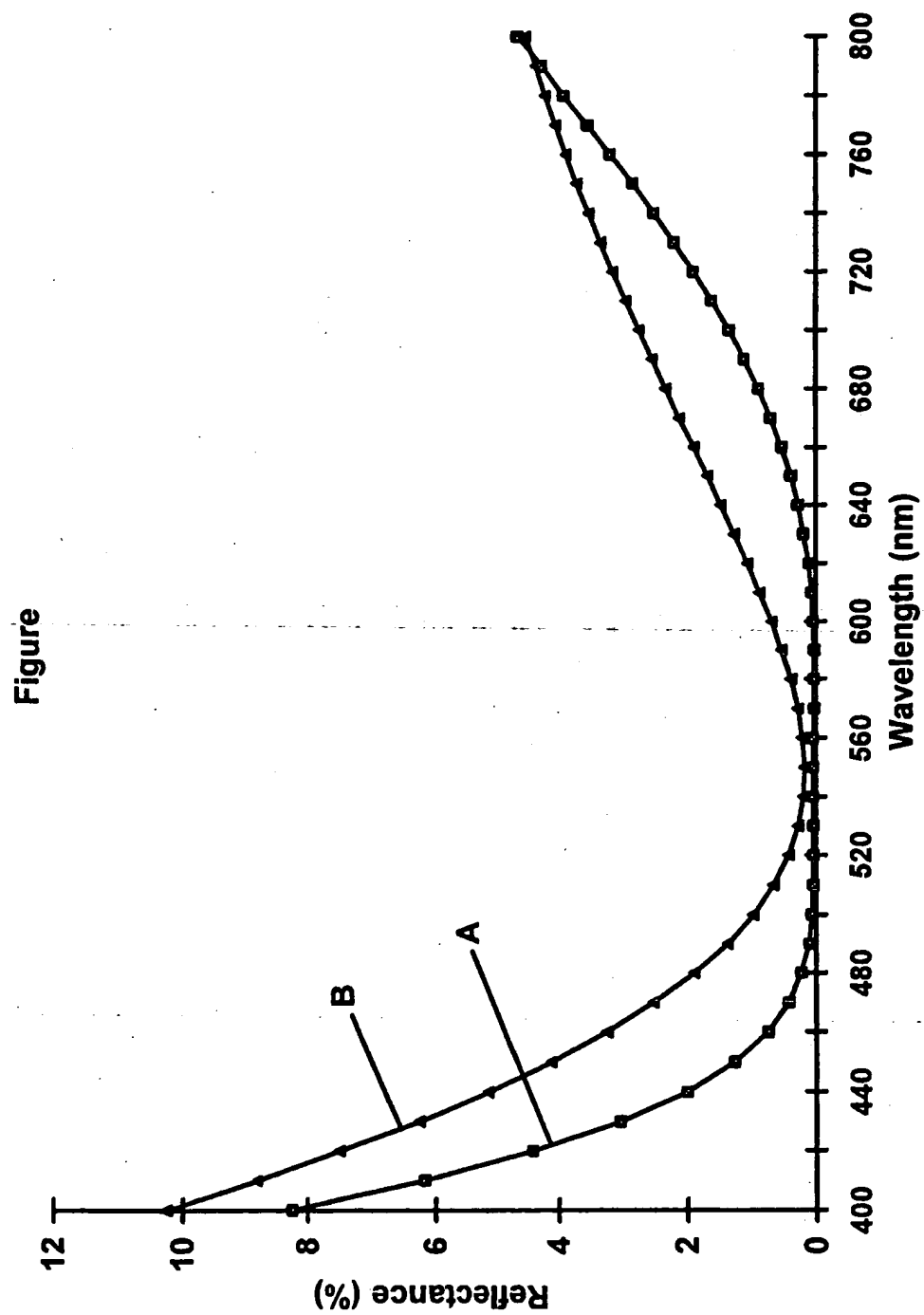
1 8. A process according to claim 7 characterized in that the
2 curable composition comprises both a polymer of a fluoroalkene and a polymer of an
3 alkyl acrylate or methacrylate, and further characterized in that the curing causes
4 segregation of material within the polymer layer, thereby producing a polymer layer
5 having an outer portion enriched in the alkyl acrylate or methacrylate and an inner
6 portion enriched in the fluoroalkene.

1 9. A process according to any one of the preceding claims
2 characterized by depositing a hard coat on the substrate before the inorganic
3 antireflection layer is deposited thereon.

1 10. A process according to any one of the preceding claims
2 characterized in that the curing of the curable composition is conducted in air.

1 11. An article having an antireflection film characterized in that the
2 antireflection film is produced by a process according to any one of the preceding
3 claims.

1/1



INTERNATIONAL SEARCH REPORT

International Application No

PCT/US 99/03589

A. CLASSIFICATION OF SUBJECT MATTER

IPC 6 G02B1/11

According to International Patent Classification (IPC) or to both national classification and IPC

B. FIELDS SEARCHED

Minimum documentation searched (classification system followed by classification symbols)

IPC 6 G02B

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched

Electronic data base consulted during the international search (name of data base and, where practical, search terms used)

C. DOCUMENTS CONSIDERED TO BE RELEVANT

Category *	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
X	WO 96 31343 A (SOUTHWALL TECHNOLOGIES INC) 10 October 1996 see page 8, line 20 - page 20, line 26; figures 1-5; examples 1,2 ---	1,2,4,6, 7,9-11
A	EP 0 749 021 A (SUMITOMO CHEMICAL CO ;DAIKIN IND LTD (JP)) 18 December 1996 see the whole document ---	1-11
A	US 5 139 879 A (AHARONI SHAUL M ET AL) 18 August 1992 see column 6, line 59 - column 9, line 26 ---	1,7
A	US 5 409 777 A (KENNEDY ALVIN P ET AL) 25 April 1995 see column 28, line 38 - column 30, line 02 --- -/--	1,7,8

☒ Further documents are listed in the continuation of box C.

☒ Patent family members are listed in annex.

* Special categories of cited documents:

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Date of the actual completion of the international search

31 May 1999

Date of mailing of the international search report

07/06/1999

Name and mailing address of the ISA

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Authorized officer

THEOPISTOU, P

INTERNATIONAL SEARCH REPORT

Interr. Application No

PCT/US 99/03589

C.(Continuation) DOCUMENTS CONSIDERED TO BE RELEVANT		
Category *	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
A	US 4 765 729 A (TANIGUCHI TAKASHI) 23 August 1988 cited in the application see column 2, line 44 - column 10, line 68 ---	1-11
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